

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Keiichi NAKAO, et al.

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Application No.: 10/529,704

Customer No.: 53080

Filed: March 29, 2005

Confirmation No.: 2023

Group Art Unit: 2832

Examiner: JOSELITO SASIS
BAISA

Title: LOAD SENSOR AND ITS MANUFACTURING METHOD

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the final Office

Action dated December 17, 2007.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.